



Sheet 1 of 1

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR 1.98(b))Attorney Docket No.:
P2002,0805Applic. No.
10/673,964

Applicant

Jenspeter Rau et al.

Filing Date
September 29, 2003Group Art Unit
1755
1752

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
My	A	2002/0042019 A1	04/11/02	Grober et al.			
	B						
	C						
	D						
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FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
u	J	39 14 407 A1	10/31/90	Germany /			X
u	K	0 469 765 A1	02/05/92	Europe /			X
	L						
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

u	O	Julie L. P. Jessop et al.: "Characterizing Acid Mobility in Chemically Amplified Resists via Spectroscopic Methods", <i>Part of the SPIE Conference on Advances in Resist Technology and Processing XVI</i> , Santa Clara, CA, March 1999, pp. 914-922
n	P	Prof. Dr. Jürgen Falbe et al. (ed.): "RÖMPP CHEMIE LEXIKON" [RÖMPP Chemistry Dictionary], 9 th ed., 1990, Georg Thieme Verlag, Stuttgart, Eintrag "Farbe" [listing color], pp. 1298-1300

EXAMINER

R C Schilling

DATE CONSIDERED

9-29-05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 (SUBSTITUTE) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))				Attorney Docket No.: P2002,0805 Appl. No.: <u>10/673964</u> Applicant: JENSPETER RAU ET AL. Filing Date: September 29, 2003 Group Art Unit: <u>1752</u>			
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>PS</i>		Plummer, J. D. et al.: "Silicon VLSI Technology", Prentice Hall Inc., 2000, pp. 221-226					
<i>PD</i>		DeMent, J.: "Handbook of Chemistry and Physics", CRC Press, 55 th Edition, 1974-1975, pp. D117-D118					
EXAMINER <i>R C Schilling</i>				DATE CONSIDERED <i>9-28-06</i>			